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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Saini et al.

Serial No. 10/799,836

§ Group Art Unit: 2879

Filed: 03/12/2004

§ Confirmation No.: 8482

For: Compact Microcolumn for automated
assembly

§ Customer No.: 000027683

§ Attorney Docket No.: 34003.110

SECOND INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited documents are listed in chronological order and are not in any order based on their pertinence.

The above-identified application is entering the United States National Phase after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of the United States Patent documents are not enclosed.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

Dave R. Hofman
Registration No. 55,272

Date: 9/5/05

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Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 4-5-05.

Karen L. Underwood

<p>APR 8 2004 U.S. PATENT & TRADEMARK OFFICE Information Disclosure Statement by Applicant (use as many sheets as necessary)</p>		<p>U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE</p>		<p>Complete if Known</p>	
				Application Number	10/799,836
				Filing Date	03/12/2004
				Applicant(s)	Saini et al.
				Art Unit	2879
				Examiner Name	To be Assigned
SHEET	1	OF	1	Attorney Docket Number	
34003.110					

NON-PATENT LITERATURE DOCUMENTS		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
	AK	Muray et al., "Advances in Arrayed Microcolumn Lithography", Journal of Vacuum Science and Technology. B, Microelectronics and Nanometer Structures Processing, Measurement and Phenomena: An Official Publication of the American Vacuum Society, Volume 18 (6), November/December 2000, pages 3099-3104. (IRN10495228)

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.